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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
YOSHIDA, Takushi et al

New York, New York
Date: January 10, 2007

Serial No.: 10/541,507

Group Art Unit: 1763

Date Filed: July 8, 2005

For: SUBSTRATE PROCESSING SYSTEM, SUBSTRATE PROCESSING
APPARATUS, PROGRAM AND RECORDING MEDIUM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on July 8, 2005.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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